


PATENT

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicants: Young Hee MUN, et al.	)	I hereby certify that this paper is being
	)	deposited with the United States Postal
Serial No.: 10/699,438	)	Service with sufficient postage as first
	)	class mail in an envelope addressed to
Filed: October 31, 2003	)	Mail Stop Amendment, Commissioner for
	)	Patents, P.O. Box 1450, Alexandria,
Title: SILICON WAFER AND	)	Virginia 22313-1450, on the date shown
METHOD OF FABRICATING	)	below.
THE SAME	)	
	)	<b>November 6, 2006</b>
Group Art Unit: 2822	)	
	)	
Examiner: GUERRERO, Maria F.	)	Andrew M. Lawrence
	)	Registration No. 46,130
Attorney Docket No.: 29936/39510	)	Attorney for Applicants

AMENDMENT "C"

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the official action dated May 5, 2006, please amend the above-identified patent application as set forth herein.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.